

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

JIN-TAE OH, ET AL.

Application No.:

Filed:

For: **High-Speed Pattern Storing and
Matching Method**

Art Group:

Examiner:

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR PRIORITY

Sir:

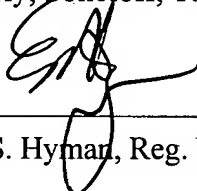
Applicant respectfully requests a convention priority for the above-captioned application, namely:

<u>COUNTRY</u>	<u>APPLICATION NUMBER</u>	<u>DATE OF FILING</u>
Korea	2003-0087885	5 December 2003

☐ A certified copy of the document is being submitted herewith.

Respectfully submitted,

Blakely, Sokoloff, Taylor & Zafman LLP



Eric S. Hyman, Reg. No. 30,139

Dated: 12/31/03

12400 Wilshire Boulevard, 7th Floor
Los Angeles, CA 90025
Telephone: (310) 207-3800